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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 9958

Masamichi NAKASHIBA et al.

Docket No. 2000-0722

Serial No. 09/589,388

Group Art Unit 3723

Filed June 8, 2000

Examiner George Nguyen

APPARATUS FOR AND METHOD FOR
POLISHING WORKPIECE

TECHNOLOGY CENTER R3700

RECEIVED
AUG 05 2003

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of January 31, 2003, the period for response to which having been extended by three months to July 31, 2003, kindly amend the above-referenced U.S. patent application as follows:

IN THE SPECIFICATION

Please insert before BACKGROUND OF THE INVENTION in column 1 and after the title the following:

REFERENCE TO RELATED APPLICATION

A continuation of this reissue application was filed May 13, 2002 and bears Serial No. 10/142,980.

IN THE CLAIMS

12. (Amended) A method of polishing a surface of a workpiece, comprising:
holding a workpiece by a top ring; and